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TIA

In re Application of: J. White, et al.

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Group Art Unit: 2824

Serial No.: 09/082,483

Examiner: P. Luu

Filed: May 20, 1998

For: **Modular Substrate
Processing System**

Assistant Commissioner for Patents
Washington, D.C. 20231

CERTIFICATE OF MAILING
37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited on 2/10/00, with the U. S. Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

2/10/00 D. Burt
Date Signature

Dear Sir:

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In response to the Office Action dated January 20, 2000, having a one-month response period set to expire on February 20, 2000, the Applicants elect claims 1-45, 47-58. —

In the claims:

Please cancel claim 46 without prejudice.

REMARKS

This response is intended as a full and complete response to the Office Action dated January 20, 2000. Restriction to one of the following inventions is required under 35 U.S.C. § 121:

I. Claims 1-45, 47-58, drawn to an apparatus for performing a process, classified in class 257, subclass 437.